

Vacuum Aligners

Robotic Components





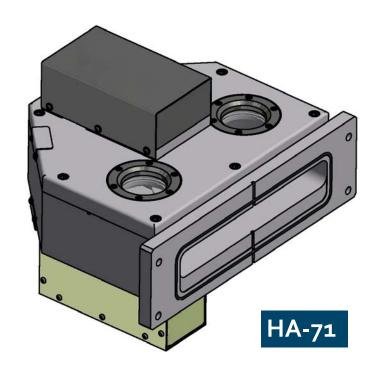
HA-7I Facet Mounted Vacuum Aligners Robotic Components

FEATURES

- High reliability of > 3 million MCBF
- Fiducial alignment and centering alignment -Delta Pick
- High vacuum compatible
- RS-232 / Ethernet control interface
- CE/S2 compliant
- Available forwafer sizes up to 300mm
- Class 1 cleanroom compatible

OPTIONS

- Translucent or Opaque wafers
- 200mm Facet or 300mm
 Facet available



Hine Automation's Vacuum Aligners are the next generation aligners. The HA-71 is a facet mounted aligner and can be integrated into any cluster system featuring a MESC mounting facet. Hine's HA-71 provides centering relative to the robotic handler and fiducial orientation for semiconductor and compound semiconductor substrates. Ferrofluidic seals, high precision DC motors, advanced CCD Array, and sophisticated software are integrated into a state-of-the-art design that make Hine Aligners a precise and reliable alignment solution for opaque and transparent substrates within high vacuum environments. Hine Aligners can be integrated with systems having any robotic arm able to execute Delta Picks.



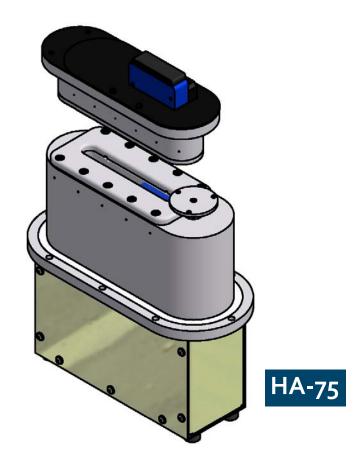
HA-75 Integrated Vacuum Aligners Robotic Components

FEATURES

- High reliability of > 3 millionMCBF
- Fiducial alignment and centering alignment -Delta Pick
- High vacuum compatible
- RS-232 / Ethernet control interface
- CE/S2 compliant
- Available for wafer sizes up to 300mm
- Class 1 cleanroom compatible

OPTIONS

- Translucent or Opaque wafers
- Accommodates wafers up to 300mm



Hine Automation's Vacuum Aligners are the next generation aligners. The HA-75 is an integrated aligner and can be integrated to any cluster system. Hine's HA-75 provides centering relative to the robotic handler and fiducial orientation for semiconductor and compound semiconductor substrates. Ferrofluidic seals, high precision DC motors, advanced CCD Array, and sophisticated software are integrated into a state-of-the-art design that make Hine Aligners a precise and reliable alignment solution for opaque and transparent substrates within high vacuum environments. Hine Aligners can be integrated with systems having any robotic arm able to execute Delta Picks.



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Vacuum Aligners

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	HA-71	HA-75
Wafer Sizes	300mm†	300mm†
Wafer Types	Opaque and Transparent	Opaque and Transparent
Mounting Facet	200mm or 300mm Facet	N/A
Aligner Enclosure Size	200mm or 300mm	Integrated Aligner
Axes of Motion	θ	θ
Vacuum Performance Base operating pressure Leak Rate	<5.00E-09 Torr 1.00E-09 scc He/sec	<5.00E-09 Torr 1.00E-09 scc He/sec
Input Power	24V DC at 2.0 Amps	24V DC at 2.0 Amps
Maximum Temperature	100°C	100°C
Exposed Materials	6061-T6 Aluminum, Stainless Steel 300 and 400 Series, Viton, Borosilicate Glass	6061-T6 Aluminum, Stainless Steel 300 and 400 Series, Viton, Borosilicate Glass
Control Interface	RS-232 / Ethernet	RS-232 / Ethernet
MCBF	>3.00E+06	>3.00E+06
CE	compliant	compliant
SEMI	compliant	compliant
Repeatability θ Centering	0.02 ⁰ ‡ <0.10mm‡	0.02 ⁰ ‡ <0.10mm‡
Calibration Wafer Included	Yes	Yes

 $^{^\}dagger$ SEMI standard sizes up to 300mm. Other sizes are available upon request. \ddagger Measured as three standard deviations (30)



About Hine Automation

Hine Automation, LLC is a designer and manufacturer of automation systems and robotic components. We serve Original Equipment Manufacturers (OEMs) in the semiconductor, solar, flat panel display and related industries across the globe. Our robotic components satisfy a wide range of needs; from flexible research and development environments to stringent manufacturing environments. Combining our unsurpassed quality and reliability with modular and versatile designs to meet today's automation challenges, our products provide functional and economical solutions.

Our Mission

Our goal is to design and manufacture the most cost effective automation solutions and deliver unparalleled customer service and support.

Our Strengths

- Demonstrated Reliability
- Cost Effective Solutions
- Custom Solutions
- Lightning Speed Response and Turn-around Times
- Knowledge, Experiencedriven Designs

Our Products

- Cluster Systems: Constellation Systems
- Automated Load Locks: Star Systems
- Robotic Components:

 Vacuum Robotic Arms

 Vacuum Elevators

 Vacuum Aligners

 Atmospheric Robotic Arms

 Atmospheric Elevators

 Atmospheric Aligners

